

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

---

In re Patent Application of:  
Nobuhiro OHKUBO et al.

Application No.: 10/786,479

Confirmation No.: 3112

Filed: February 26, 2004

Art Unit: 2828

---

For: SEMICONDUCTOR LASER DEVICE AND  
MANUFACTURING METHOD THEREOF

---

Examiner: T. T. Van Roy

**AMENDMENT UNDER 37 CFR 1.116**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Action dated November 16, 2007, please amend the application as follows.

**Amendments to the Claims** begin on page 2.

**Remarks/Arguments** begin on page 5.

**Not Entered**  
**02/25/08**  
**Tod T. Van Roy**